

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1792**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

Group Art Unit: 1792

Application No.: 10/587,500

Examiner: K. STOUFFER

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
APPARATUS FOR PROCESSING SUBSTRATE

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 8, 2009 Office Action, the period for response having been extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.